



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Yuichiro MATSHUO et al.**

Group Art Unit: **1753**

Application Number: **10/715,403**

Examiner: **Edna Wong**

Filed: **November 19, 2003**

Confirmation Number: **1169**

For: **NEGATIVE ION GENERATING MEDIUM AND ITS  
MANUFACTURING METHOD**

Attorney Docket Number: **032114**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

September 22, 2005

Sir:

In response to the Office Action dated April 26, 2005, the response date of which having been extended by two (2) month to September 26, 2005, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 4 of this paper.

Remarks begin on page 8 of this paper.